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	Application No.	Applicant(s)	
Madian of Allin 1994	10/736,988	736,988 OTTENS ET AL.	
Notice of Allowability	Examiner	Art Unit	
	Hung Henry V. Nguyen	2851	
The MAILING DATE of this communication apperature All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RI of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in this ap or other appropriate communicatior GHTS. This application is subject to	plication. If not included will be mailed in due course. T	HIS nitiative
1. This communication is responsive to <u>10/6/05</u> .			
2. The allowed claim(s) is/are 1-13.	·		
3.	been received. been received in Application Nocuments have been received in this of this communication to file a reply ENT of this application. tted. Note the attached EXAMINER s reason(s) why the oath or declara	national stage application from complying with the requirement 'S AMENDMENT or NOTICE Otion is deficient.	s
1) hereto or 2) to Paper No./Mail Date			
(b) ☐ including changes required by the attached Examiner's Paper No./Mail Date			
Identifying indicia such as the application number (see 37 CFR 1. each sheet. Replacement sheet(s) should be labeled as such in the	ne header according to 37 CFR 1.121(d).	
 DEPOSIT OF and/or INFORMATION about the depose attached Examiner's comment regarding REQUIREMENT F 			
Attachment(s) 1. ☑ Notice of References Cited (PTO-892)	5 □ Notice of Informal R	atent Application (DTO 152)	
2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948)	6. ☐ Interview Summary	atent Application (PTO-152) (PTO-413)	
3. ☐ Information Disclosure Statements (PTO-1449 or PTO/SB/06	Paper No./Mail Dat	e	
Paper No./Mail Date 4. ☐ Examiner's Comment Regarding Requirement for Deposit	8. X Examiner's Stateme	ent of Reasons for Allowance	
of Biological Material	9. Other	Hruberun_	
		HENRY HUNG NGUYEN PRIMARY EXAMINER	

DETAILED ACTION

Continued Examination Under 37 CFR 1.114

1. A request for continued examination under 37 CFR 1.114, including the fee set forth in 37 CFR 1.17(e), was filed in this application after final rejection. Since this application is eligible for continued examination under 37 CFR 1.114, and the fee set forth in 37 CFR 1.17(e) has been timely paid, the finality of the previous Office action has been withdrawn pursuant to 37 CFR 1.114. Applicant's submission filed on October 6, 2005 has been entered.

Reasons for Allowance

2. The following is an examiner's statement of reasons for allowance: Claims 1-13 have been found to be allowable since the prior art of record either alone or in combination neither discloses nor makes obvious the combination of an article support and corresponding lithographic projection apparatus comprising a clamp having a plurality of zones located substantially continuously around a circumference of the article support for generating a locally adjusted pressure so as to provide a local bending moment near the edge of the article to locally bend the article, as recited in the instant claims of the present invention. Applicant's arguments filed October 6, 2005 are deemed persuasive and incorporated herein by references.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

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Prior Art Made of Record

3. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure.

Takahashi (U.S.Pat. 6,135,858) is cited for its teaching of a substrate holding device having a frame member for supporting the substrate and a plurality of fluid chambers positioned concentrically in the recess of the frame member and a controller for controlling the pressure inside of each of the fluid chambers.

4. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Hung Henry V. Nguyen whose telephone number is 571-272-2124. The examiner can normally be reached on Monday-Friday (First Friday off).

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Judy Nguyen can be reached on 571-272-2258. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

hvn 10/19/05

HENRY HUMG NGUYEN
PRIMARY EXAMINER

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